## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of: Navaz Lulla et al.

Serial No.: 09/689,532

Title: CIRCUIT FOR GENERATING SILICON ID FOR PLDS

Filed: October 12, 2000

Attorney Docket No.: 0325.00420

Examiner: Whitmore, S.

Art Unit: 2812

In Response To: Office Action mailed March 26, 2004

I hereby certify that this letter, the response or amendment attached hereto are being deposited with the United States Postal Service as first class mail in an envelope addressed to Mail Stop AF, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on <u>May 26, 2004</u>.

AMENDMENT AFTER FINAL

Mail Stop AF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed March 26, 2004 please amend the above-identified application as follows: